

Fabrications and electrical properties of Co doped Bi₂Te₃ thin films deposited by direct current magnetron sputtering

班級/學號/姓名:材四甲 U07187002 王維澤&材四甲 U07187025 莊珉禎

指導教授:陳勝吉

Abstract

Bismuth telluride is a thermoelectric material at room temperature, and its electrical properties have an important influence on the thermoelectric conversion efficiency. In this study, a DC magnetron sputtering system was used to sputter the bismuth telluride thin film by co-sputtering and introducing cobalt to try to improve its thermoelectric properties. By adjusting the sputtering power of the cobalt target and fixing the bismuth target and the tellurium target Sputtering power to control the amount of doping.



Thermoelectric application



Conclusion

- 1.Co element will contribute large amount of point defect, that can provide free electron and help to reduce resistivity.
- 2. When the Co element was introduced into Bi_2Te_3 film, no Co phase was form, But we found Co doping will refine the crystal grains, cause more interfaces in the film, and make carriers and phonons more likely to be scatter during the transport process, thus improving the thermoelectric properties.
- 3. We found the highest power factor 260 uW/m-K² at 2.5 at.% Co.